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JC598 U.S. PTO
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned
Examiner: To Be Assigned

In Re PATENT APPLICATION Of:

Applicant	:	Hiroki NAKAMURA)	
Appln. Ser. No.	:	To Be Assigned)	
Filed	:	Herewith)	INFORMATION
For:	SEMICONDUCTOR DEVICE AND METHOD))	DISCLOSURE
	FOR MANUFACTURING THE SAME))	STATEMENT
Attorney Ref.	:	F98ED0762)	

Director of Patents and Trademarks
Washington, D.C.20231

Sir:

This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. § 1.97(b)(1).

Attached are copies of two Japanese laid open patent documents. The documents are listed on the attached Form PTO-1449. Moreover, English language abstracts of these documents are also attached.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§ 1.97 and 1.98 are deemed to be fully met as to all documents submitted. Consideration of the submitted documents is respectfully requested.

Respectfully submitted,

July 25, 2000
Date



Junichi Mimura (Reg. No. 40,351)
Oki America, Inc.
1101 14th Street, N.W., Suite 555
Washington, D.C. 20005
Telephone: (202) 452-6190
Telefax: (202) 452-6148

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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT		Atty Docket	U.S. Application No.:				
		F98ED0762	To Be Assigned				
		Applicant	Hiroki NAKAMURA				
U.S. Filing Date: July 25, 2000		Group	To Be Assigned				
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
A.N	AL ✓	09139431 A	5/27/97	Japan	H01L	21/82	Abstract
A.M ✓	AM	10178011 A	6/30/98	Japan	H01L	21/3205	Abstract
	AN						
	AO						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AR						
	AS						
Examiner	A.N H D. M.Ai			Date Considered <u>12/19/01</u>			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							